

# WEST Search History

DATE: Thursday, September 19, 2002

## Set Name Query side by side

## Hit Count Set Name result set

*DB=USPT; PLUR=YES; OP=ADJ*

L41	LEE-CHENG!	6	L41
L40	l37 and l38	9	L40
L39	L38 or l37	95999	L39
L38	l13 or polish\$4	95968	L38
L37	l31 and l36	40	L37
L36	l35 or l33	34482	L36
L35	(wet or liquid) near5 etch\$4	22745	L35
L34	l31 and l33	1	L34
L33	BOE or l15	12657	L33
L32	l31 and l13	9	L32
L31	l26 and l29	116	L31
L30	PVD	5650	L30
L29	sputter\$4	68352	L29
L28	L27 and l13	2	L28
L27	L26 and l6	19	L27
L26	L20 and l9	307	L26
L25	l20 and l13	10	L25
L24	l23 and l13	2	L24
L23	l20 and l22	9	L23
L22	l9 same l6	2609	L22
L21	L20 and l10	4	L21
L20	L19 and l4	312	L20
L19	L18 and l5	1719	L19
L18	L17 and l1	2042	L18
L17	L2 or l3	2912	L17
L16	l1, or l2	261790	L16
L15	buffered oxide etch\$4	979	L15
L14	remov\$4 or etch\$4	1646862	L14
L13	L12 or l11	15156	L13
L12	chemical adj2 mechanical adj2 polish\$4	10251	L12
L11	CMP	12434	L11

L10	19 near10 l6	1418	L10
L9	18 or l7	2529809	L9
L8	"Al"	2476357	L8
L7	aluminum	458488	L7
L6	sputter near5 deposit\$4	8245	L6
L5	open\$4 or hole\$1 or via\$1	2089616	L5
L4	polyimide	50779	L4
L3	input/output pad\$1	1398	L3
L2	I/O pad\$1	1897	L2
L1	semiconduct\$4	261187	L1

END OF SEARCH HISTORY